



PATENT  
8053-1016

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Kazuhiro NAKAJIMA et al.

Conf. 9942

Application No. 10/625,695

Group 2811

Filed July 24, 2003

Examiner Ori Nadav

PRODUCTION PROCESS FOR PRODUCING  
SEMICONDUCTOR DEVICES, SEMICONDUCTOR  
DEVICES PRODUCED THEREBY, AND TEST  
SYSTEM FOR CARRYING OUT YIELD-RATE  
TEST IN PRODUCTION OF SUCH  
SEMICONDUCTOR DEVICES

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

MS AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the accompanying document, a copy of which is attached to this statement, is made of record on the enclosed Form PTO-1449.

A concise explanation of the relevance of this item is that this reference was cited by the Japanese Patent Office in the corresponding Japanese Application Serial No. 2002-279397, filed September 25, 2002. A copy of the Japanese Official Action in which it was cited is attached hereto, with what is believed to be the pertinent portion enclosed in a wavy line. An English translation of the enclosed portion is also attached hereto.

Under the provisions of 37 CFR 1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Statement.

Charge the petition fee of \$180 to deposit account No. 25-0120.

Respectfully submitted,

YOUNG & THOMPSON

A handwritten signature in black ink, appearing to read 'Robert J. Patch', written over a horizontal line.

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RJP/fb

July 26, 2005

(Use several sheets if necessary)

Group Art Unit:  
**2811**

[illegible][illegible]


DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

Y&T May 27, 2005